## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Ulrich Bonne Examiner: Christine T. Mui

Serial No.: 10/749,863 Confirmation No: 6317

Filing Date: December 31, 2003 Group Art: 1797

For: MICRO-PLASMA SENSOR SYSTEM
Docket No.: H0005829-1100.1222101

## AMENDMENT

Mail Stop Amendment Assistant Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

## CERTIFICATE OF ELECTRONIC TRANSMISSION

I hereby certify that this paper is being electronically transmitted to the United States Patent and Trademark Office on the date shown below.

Lynn Thompson Date

This Amendment is being filed in response to the Official Action of the Examiner mailed April 8, 2008.

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.